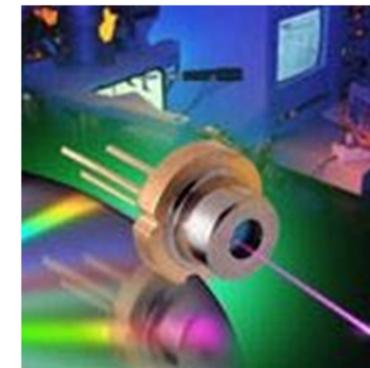


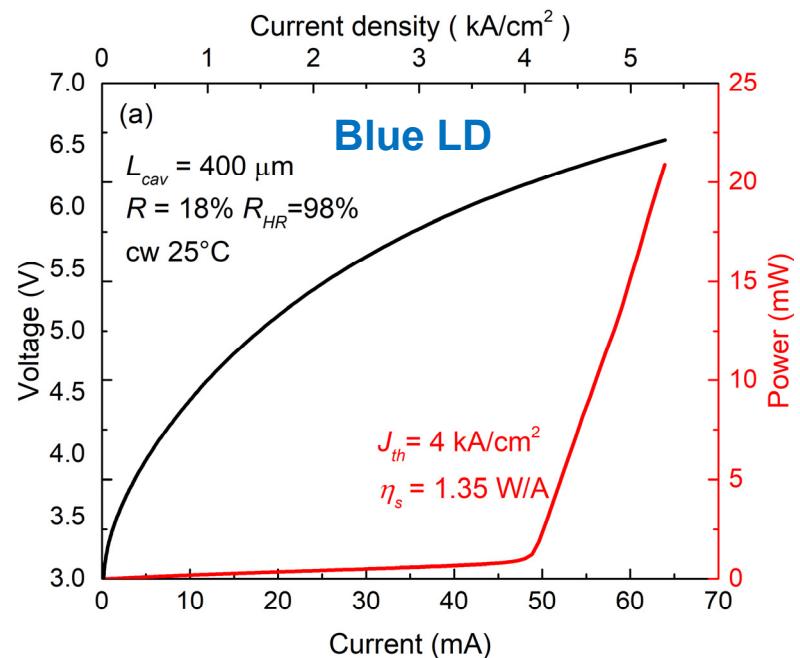
# Lecture 12 – 14/05/2025

## Laser diodes

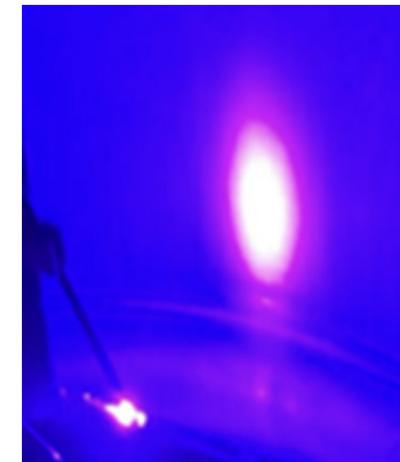
- Generalities
- Electrical injection
- Material gain: bulk and QW cases
- Laser oscillations
- Output power



# Laser diodes



Far-field pattern

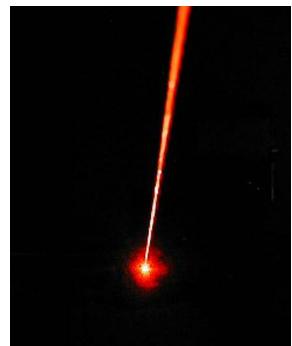


Laser: a clear threshold is observed in the  $L$ - $I$  curve (+ far-field pattern)

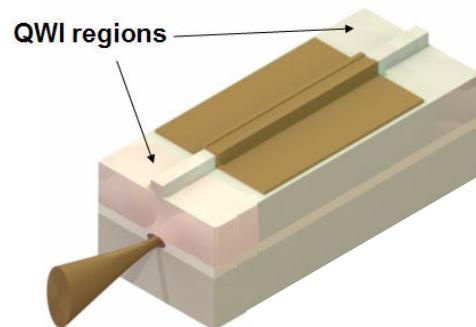
⇒ Light amplification

***Light Amplification by Stimulated Emission of Radiation***

# Semiconductors: a brief overview

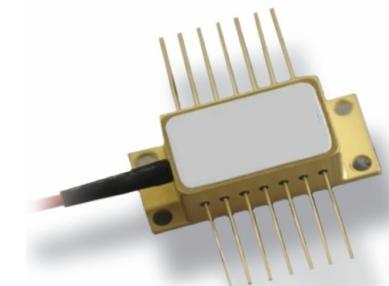
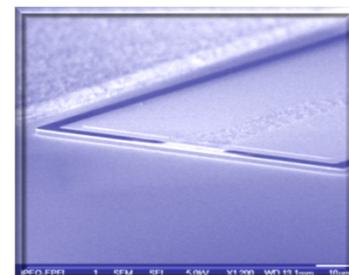


1970  
1<sup>st</sup> laser diode  
 $\lambda \sim 780$  nm  
 $J_{thr} \sim 4.3$  kA/cm<sup>2</sup>  
Ioffe, Russia



1980's

**GaAs**  
based  
optoelectronics



2000

CD, DVD, Telecom

**BUT** light emission limited to the **Red** and **IR**

# Semiconductors: a brief overview

---

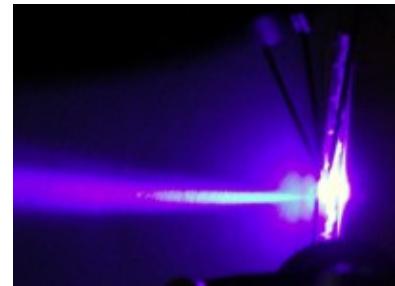


1993

1990's



**GaN**  
**short-wavelength**  
**optoelectronics**

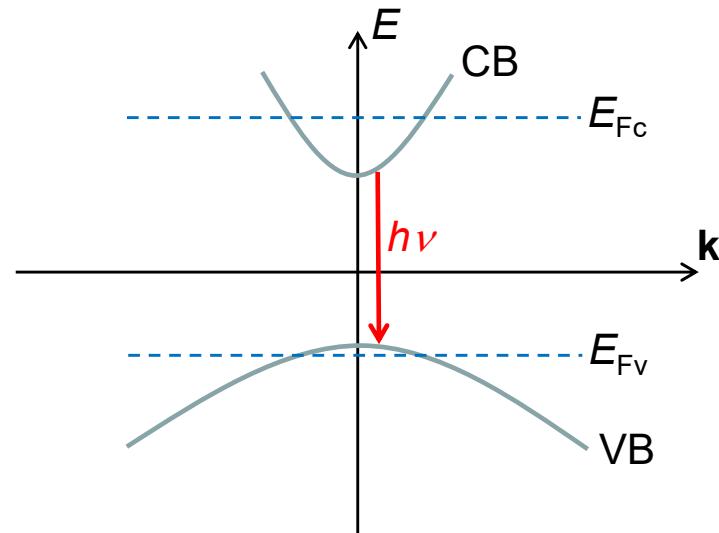


2003

Demonstration of reliable (i.e., long lifetime) green semiconductor laser diodes with a high production yield on the way (available from Nichia. Inc.)!

# Electrical injection

- Both the valence and the conduction bands get more and more filled upon increasing current injection
- The carrier populations are described by the quasi-Fermi levels  $E_{Fc}$  and  $E_{Fv}$



$$f_c(E) = \frac{1}{\exp\left(\frac{E - E_{Fc}}{k_B T}\right) + 1}$$

$$f_v(E) = \frac{1}{\exp\left(\frac{E - E_{Fv}}{k_B T}\right) + 1}$$

Note that here  $f_v(E)$  describes the evolution of the electron population in the valence band!

# Electrical injection

## Different paths for electron-hole recombinations

- Non-radiative
- Spontaneous
- Auger
- Stimulated

$$A_{nr}n$$

$$Bn^2$$

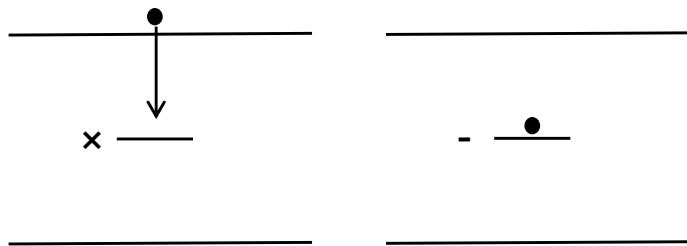
$B$  bimol. coeff.  $\sim 10^{-12}$ - $10^{-10} \text{ cm}^3\text{s}^{-1}$

$$Cn^3$$

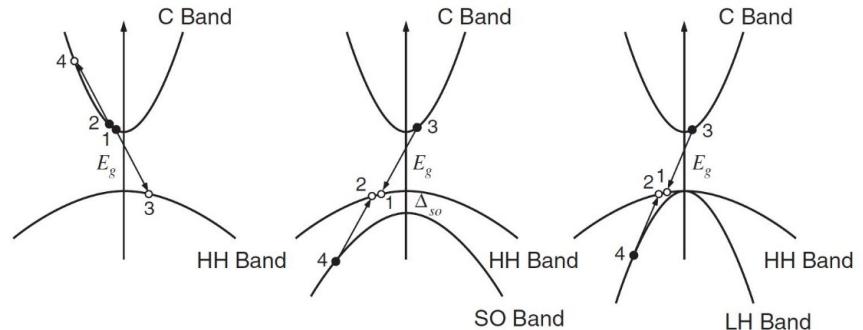
$$R_{st}s$$

with  $R_{st} = -R_{abs}$  and  $s$  the density of stimulated photons

*Stimulated recombination rate*



Shockley-Read-Hall  
recombinations



Auger  
recombinations

# Electrical injection

## Below threshold – spontaneous emission regime ( $s = 0$ )

$$R_{\text{tot}} V (= Sd) = J/q \quad S \Rightarrow R_{\text{tot}} = J/(qd) = A_{\text{nr}}n + Bn^2 + Cn^3$$

$d$  = active region thickness

$$1/\tau_{\text{nr}} = A_{\text{nr}} + Cn^2$$

Non radiative recombinations

$$1/\tau_r = Bn$$

Radiative recombinations

$$\text{with } 1/\tau_{\text{tot}} = 1/\tau_r + 1/\tau_{\text{nr}}$$

Finally  $R_{\text{tot}} = (1/\tau_{\text{nr}} + 1/\tau_r)n = J/(qd)$  and  $n = J\tau_{\text{tot}}/(qd)$

One recalls that the internal quantum efficiency (IQE) is given by

$$\eta_i = \frac{\tau_{\text{tot}}}{\tau_r} = \frac{\tau_{\text{nr}}}{\tau_{\text{nr}} + \tau_r} = \frac{Bn}{A_{\text{nr}} + Bn + Cn^2}$$

and the photon flux is given by  $\phi = \eta_{\text{inj}} \eta_i J/q$

Often taken equal to 1 (assumption we make from now on)!

# Electrical injection

---

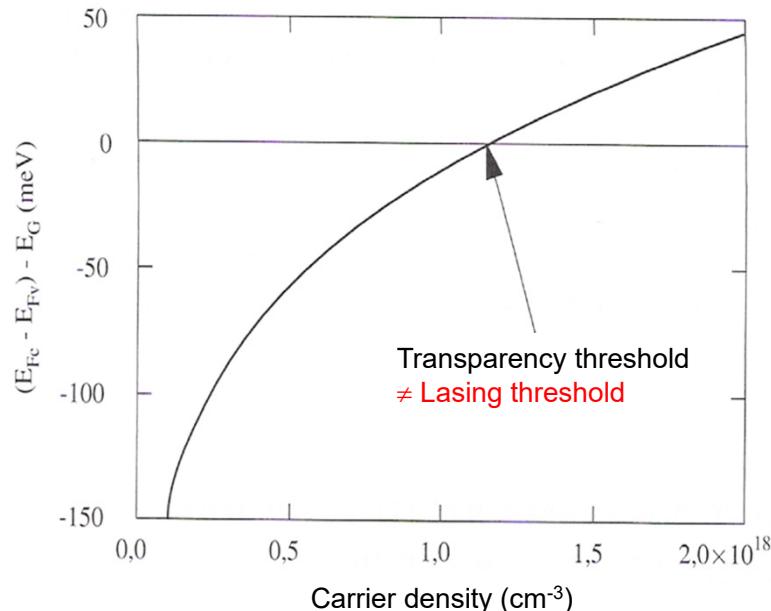
$$n = J\tau_{\text{tot}}/qd$$

## A few remarks:

- *The effective recombination lifetime  $\tau_{\text{tot}}$  depends on the carrier density*
- *The Auger recombination term is significant only at high injection*
- *The carrier density depends on the active region thickness*

- homojunction:  $d = L_{Dn} + L_{Dp}$  (1-10  $\mu\text{m}$ )
- heterojunction:  $d = 100 \text{ nm}$
- quantum well:  $d = 1-10 \text{ nm}$

# Stimulated emission



The material becomes transparent when

$$E_{F_c} - E_{F_v} = E_g \quad \text{True for a bulk SC!}$$

Minimum requirement to fulfill the Bernard-Duraffourg condition (cf. fall semester, **Lecture 12**)

## Transparency threshold in GaAs

$d = 1 \mu\text{m} \Rightarrow J_{tr} \sim 16 \text{ kA/cm}^2$  bulk (1960)

$d = 100 \text{ nm} \Rightarrow J_{tr} \sim 1.6 \text{ kA/cm}^2$  heterojunction (1970) ( $\equiv$  double heterostructure (DHS))

$d = 10 \text{ nm} \Rightarrow J_{tr} \sim 160 \text{ A/cm}^2$  quantum well (1980) ( $\equiv$  separate confinement heterostructure (SCH))

# Stimulated emission

---

$n$  increases with the current

$$n = \int_{E_c}^{\infty} \rho_c(E) \frac{1}{\exp\left(\frac{E - E_{Fc}}{k_B T}\right) + 1} dE \quad E_{Fc} (E_{Fv}) \uparrow$$

and the absorption is given by

$$\alpha(\omega) = -\gamma(\omega) = \alpha_0(\omega) [f_v(\hbar\omega) - f_c(\hbar\omega)] \quad \text{where } \gamma \text{ is the gain}$$

When  $\alpha$  becomes negative, stimulated emission becomes possible (but one extra condition must be fulfilled for achieving lasing)

$$f_c(\hbar\omega) \geq f_v(\hbar\omega) \Rightarrow E_{Fc} - E_{Fv} \geq \hbar\omega \geq E_g$$

**Bernard-Duraffourg condition**

Light gets amplified only once the **Bernard-Duraffourg condition** is fulfilled, i.e., when the semiconducting medium exhibits **optical gain**!

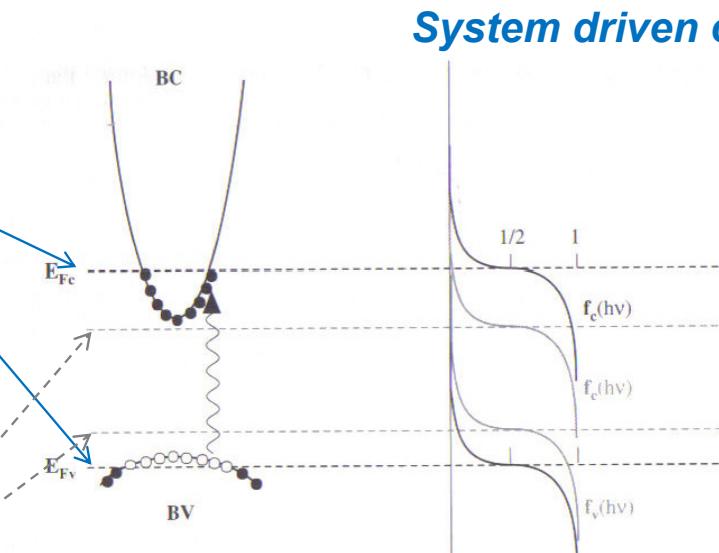
⇒ Necessary condition for the achievement of lasing in a semiconducting medium (⚠ but it is not a sufficient one)

# Stimulated emission

$$E_{Fc} - E_{Fv} > \hbar\omega > E_g$$

- Strong excitation
  - ✓ At least one of the bands is degenerate
  - ✓ All the states satisfying the *B-D* inequality are “fully occupied”, i.e. the SC is transparent for those  $\lambda$ !

- Weak or moderate excitation
  - ✓ None of the bands are degenerate, i.e.  $n < N_C$  and  $p < N_V \Rightarrow$  use of Boltzmann approximation
  - ✓  $\Rightarrow$  photon absorption is still at play since there are available states in the CB where  $e^-$  from the VB can be promoted

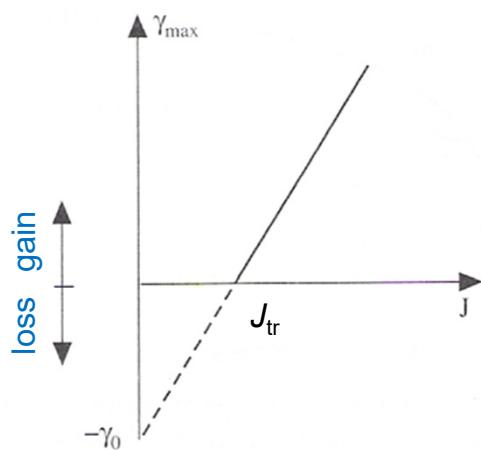
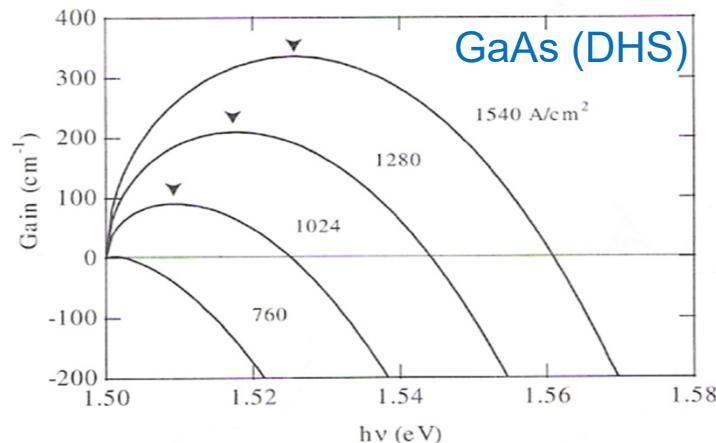


**System driven out of equilibrium**

Cf. slide 17 of Lecture 9  
and related comments!

# Material gain (bulk case)

## Gain curves



In a semiconductor, the material gain can also be expressed as

$$\gamma(h\nu) = \frac{\lambda^2}{8\pi\tau_r} \rho_j(h\nu) [f_c(h\nu) - f_v(h\nu)]$$

JDOS

Increase and broadening of the gain region with the current

*In a bulk system, the maximum gain varies linearly with the carrier density  $n$  above the transparency carrier density  $n_{tr}$*

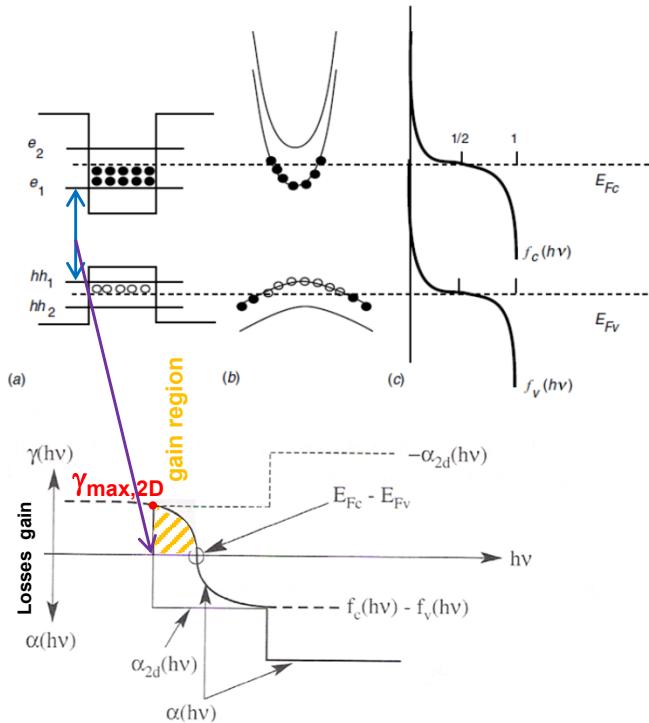
$$\gamma_{max} = \gamma_0 \left( \frac{n}{n_{tr}} - 1 \right)$$

$$\Rightarrow \gamma_{max} \approx \gamma_0 \left( \frac{J}{J_{tr}} - 1 \right)$$

knowing that  $J_{tr} = \frac{qd}{\tau_{tot@tr}} n_{tr} = \frac{qd}{\eta_i \tau_{r@tr}} n_{tr}$

⚠ Keep in mind the nonlinear relationship between the current density and the carrier density (⇒ ABC-model)!

# Material gain (QW case)



Cf. Lecture 12, fall semester for 3D case!  
+  
Rosencher-Vinter's book

Note: The zero of energy is taken at the top of the valence band

## Case of quantum wells:

Quasi-Fermi levels derived from

$$n = \int_{\substack{e_1' = E_g + e_1 \\ -h h_1}}^{\infty} \rho_{2D}^e(E) f_c^1(E) dE$$

$$p = \int_{-\infty}^{\infty} \rho_{2D}^{hh}(E) (1 - f_v^1(E)) dE$$

Note: only the ground states are populated at the transparency threshold

## Material gain for the $e_1$ - $hh_1$ transition

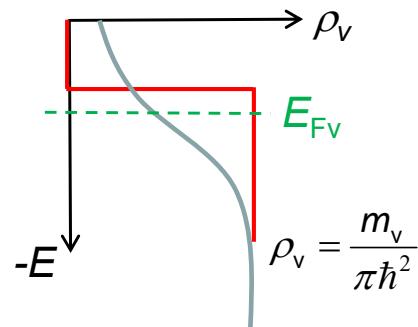
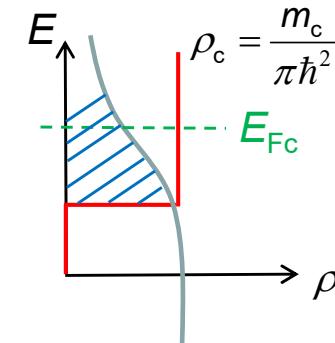
$$\gamma(hv) = \alpha_{2D} \left[ f_c^1(hv) - f_v^1(hv) \right] \theta(hv - E_g - e_1 - h h_1)$$

$$\text{with } \alpha_{2D}(\hbar\omega) = \frac{\pi q^2 x_{vc}^2 \omega}{\epsilon_0 n_{op} c d} \rho_{2D}(\hbar\omega) = \frac{2\pi q^2 x_{vc}^2 m_r^*}{\epsilon_0 \hbar^2 n_{op} \lambda d}$$

2D-JDOS

# Material gain (QW case)

## Quantum well:



$$n = \int_{e'_1 = E_g + e_1}^{+\infty} \rho_c \frac{1}{\exp\left(\frac{E - E_{Fc}}{k_B T}\right) + 1} dE \Rightarrow n = n_c \ln\left(1 + \exp\left(\frac{E_{Fc} - e'_1}{k_B T}\right)\right)$$

$$n_c = \rho_c k_B T$$

$$p = \int_{-\infty}^{-hh_1} \rho_v \frac{1}{\exp\left(\frac{E_{Fv} - E}{k_B T}\right) + 1} dE \Rightarrow p = p_c \ln\left(1 + \exp\left(-\frac{hh_1 + E_{Fv}}{k_B T}\right)\right)$$

$$p_c = \rho_v k_B T \quad \text{and} \quad n_c/p_c = \rho_c/\rho_v = m_c/m_v = 1/R$$

$n_c$  and  $p_c$  are the 2D critical densities

Note: The zero of energy is taken at the top of the valence band!

⚠ not to be confused with the reflectivity coefficient!

# Material gain (QW case)

## Quantum well:

The material gain exhibits its maximum at the absorption edge due to the staircase profile of the 2D-DOS

Maximum gain for  $\hbar\omega = \Delta E = e'_1 + hh_1 \Rightarrow E_c(\hbar\omega) = e'_1$  and  $E_v(\hbar\omega) = -hh_1$

$$\Rightarrow \gamma_{\max} = \gamma_0 (f_c(\Delta E) - f_v(\Delta E)) = \gamma_0 \left( \frac{1}{\exp\left(\frac{e'_1 - E_{F_c}}{k_B T}\right) + 1} - \frac{1}{\exp\left(-\frac{hh_1 + E_{F_v}}{k_B T}\right) + 1} \right) \text{ with } \gamma_0 = \alpha_{2D}$$

$$E_{F_c} - e'_1 = k_B T \ln(e^{n/n_c} - 1)$$

$$- (hh_1 + E_{F_v}) = k_B T \ln(e^{p/p_c} - 1)$$

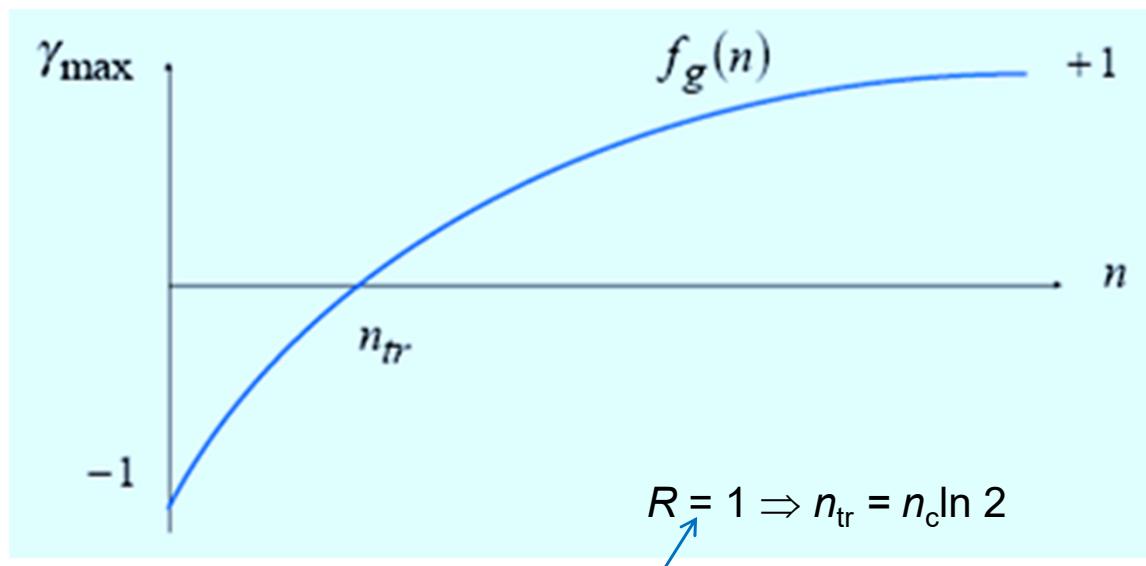
$$\gamma_{\max} = \gamma_0 f_g(n) \quad \text{with} \quad f_g(n) = 1 - e^{-n/n_c} - e^{-n/p_c} \quad \text{and} \quad n = p \quad \text{due to electrical neutrality}$$

$$f_g(n) = 1 - e^{-n/n_c} - e^{-n/Rn_c} \quad \text{with} \quad R = \frac{m_v}{m_c}$$

# Material gain (QW case)

Quantum well:

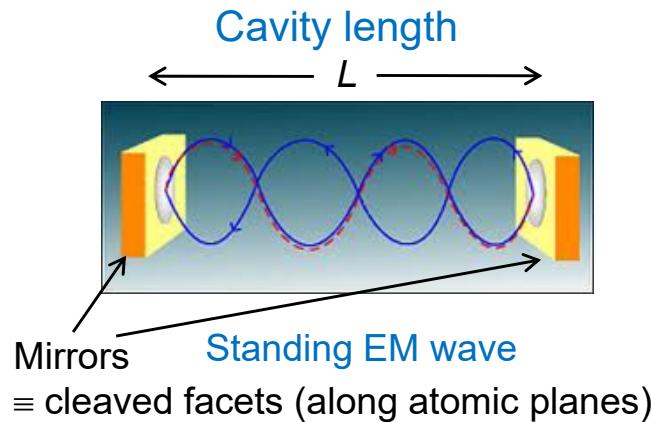
$$\text{Transparency when } f_g(n) = 1 - e^{-n/n_c} - e^{-n/Rn_c} > 0$$



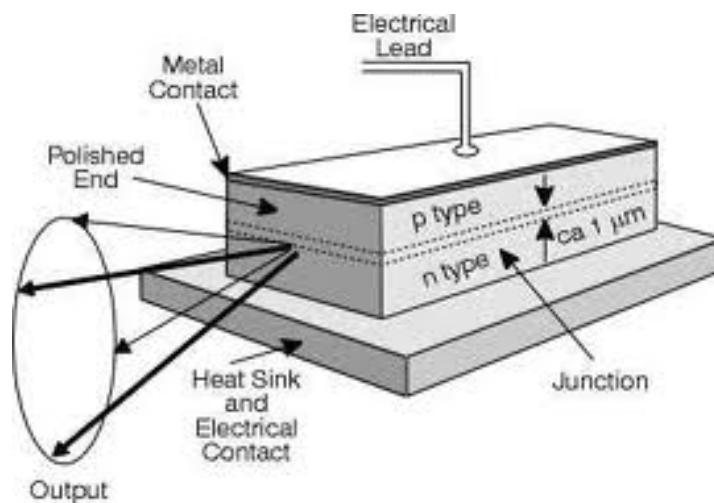
$$R = 1 \Rightarrow n_{tr} = n_c \ln 2$$

Fictitious but illustrative example!

# Edge-emitting laser diode



Resonant cavity  $\Rightarrow$  optical feedback



$$R_m = (n_{sc}-1)^2 / (n_{sc}+1)^2$$

E.g., for GaAs,  $R_m = 0.32$

# Laser oscillations

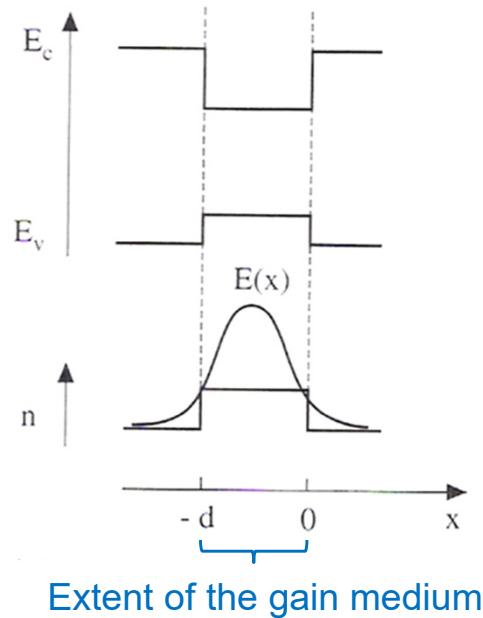
## Condition for lasing:

$$\text{Modal gain} = \text{losses} \Rightarrow \Gamma \gamma_{\text{thr}}(h\nu) = \alpha_p + \frac{1}{2L} \times \ln(1/R_1 R_2)$$

Modal gain  
= confinement factor  $\times$  material gain

Parasitic or intrinsic losses  
Mirror losses

## Optical waveguide:



*Overlap between optical mode and active region (gain medium, e.g., QWs)*

The confinement factor ( $\Gamma$ ) is given by:

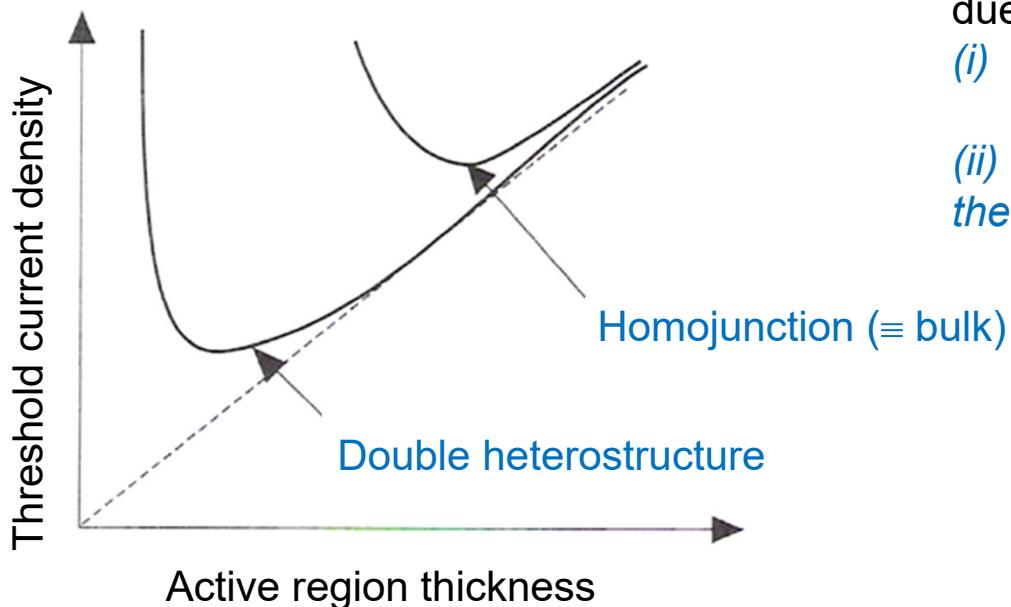
$$\Gamma = \frac{\int_{-d}^{0} |E(x)|^2 dx}{\int_{-\infty}^{+\infty} |E(x)|^2 dx}$$

For a QW-based LD (SCH),  $\Gamma = 0.5\text{-}5\%$   
For a double heterostructure (DHS),  $\Gamma \sim 1$  ( $d \approx 100$  nm)

# Laser oscillations

## Condition for lasing:

$$\Gamma \gamma_{\text{thr}}(h\nu) = \alpha_p + 1/(2L) \times \ln(1/R_1R_2)$$



Lower  $J_{\text{thr}}$  of DHS-LDs vs. homojunction ones due to:

- (i) *better confinement of carriers*
- (ii) *better overlap between the gain region and the EM field*

# Output power

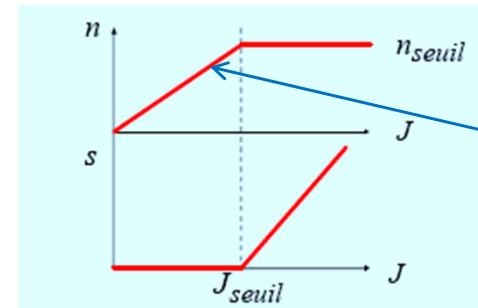
1. Below the transparency threshold: weak contribution due to spontaneous emission emitted through the outcoupling mirror/facet
2. Above the transparency threshold: amplified spontaneous emission (ASE),  
 $\Rightarrow$  *superluminescence*
3. When  $\Gamma\gamma$  (modal gain) equals the losses: laser oscillations start

Important: once the lasing threshold is reached, the carrier density is clamped (constant)



*each newly added electron gives rise to 1 stimulated photon (x IQE)*

*The feedback effect causes the carrier density to clamp in order to keep the gain at its threshold value!*



Approximate description since  $n$  is not a linear function of  $J$ !

# Output power

## Equation

$$J/(qd) = A_{nr}n + Bn^2 + Cn^3 + R_{st}s$$

$n = n_{thr}$  above threshold:

$$J/(qd) = n_{thr}/\tau_{thr} + R_{st}s$$

$$J_{thr} = q d n_{thr}/\tau_{thr} (s = 0)$$

$$\Rightarrow R_{st}s = (J - J_{thr})/qd$$

$R_{st}$ : stimulated emission rate  
 $s$ : density of stimulated photons

The stimulated emission rate is given by  $R_{st} = \gamma_{thr} c/n_{op} = 1/(\Gamma \tau_{cav})$  (cf. rate eqs. in Lectures 13 & 14)

Finally, the density of photons inside the cavity is given by:

$$s = (n_{op}/(qd\gamma_{thr}c))(J - J_{thr}),$$

$\Rightarrow$  all the current above threshold is converted in stimulated emission!

In practice, one must also account for nonradiative channels (i.e., the IQE is included)

$$s = \eta_i(n_{op}/(qd\gamma_{thr}c))(J - J_{thr})$$

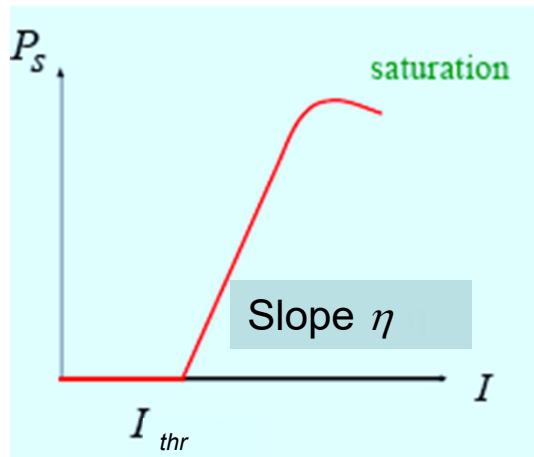
# Output power

$$\tau_{\text{cav}} = n_{\text{op}}/(\Gamma \gamma_{\text{thr}} c) \Rightarrow s = \eta_i (\Gamma \tau_{\text{cav}}/qd)(J-J_{\text{thr}}) \quad \gamma_{\text{thr}} = (\alpha_m + \alpha_p)/\Gamma \quad c' = c/n_{\text{op}}$$

$$P_s = \underbrace{(\text{Photon energy})}_{h\nu} \underbrace{(\text{Photon density})}_{\eta_i \frac{\Gamma \tau_{\text{cav}}}{qd} (J-J_{\text{thr}})} \underbrace{(\text{Effective mode volume})}_{Sd/\Gamma} \underbrace{(\text{Photon escape rate})}_{c' \alpha_m}, \quad I = JS$$

$$P_s = \eta_i \frac{\alpha_m}{\alpha_p + \alpha_m} \frac{h\nu}{q} (I - I_{\text{thr}}) \Rightarrow P_s = \eta \frac{h\nu}{q} (I - I_{\text{thr}})$$

where we assumed that the injection efficiency = unity



## Wall plug efficiency (WPE)

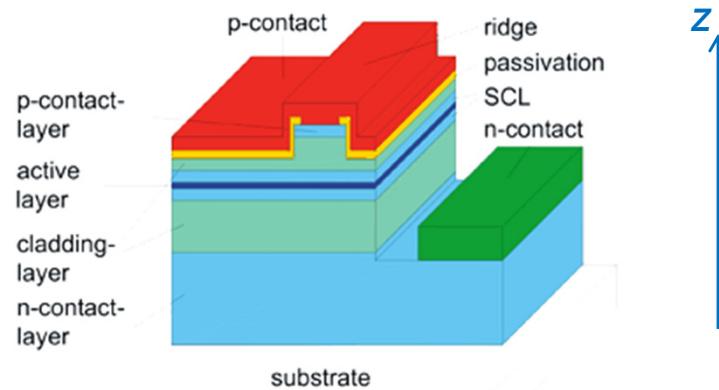
$$P_{\text{el}} = V \times I \approx h\nu/q \times I \text{ (assuming cold carrier injection)}$$

$$P_s/P_{\text{el}} = \text{WPE} \approx \eta (1 - I_{\text{thr}}/I)$$

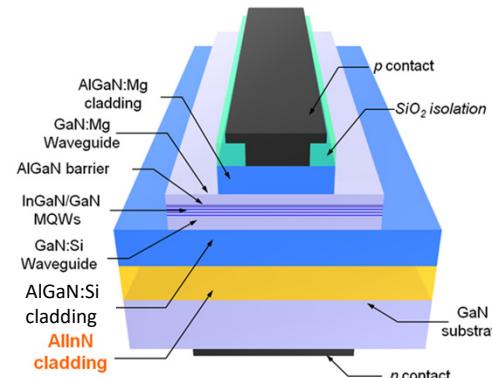
External quantum efficiency

> 30% for semiconductor lasers  
1% for gas lasers

# Edge-emitting laser diode

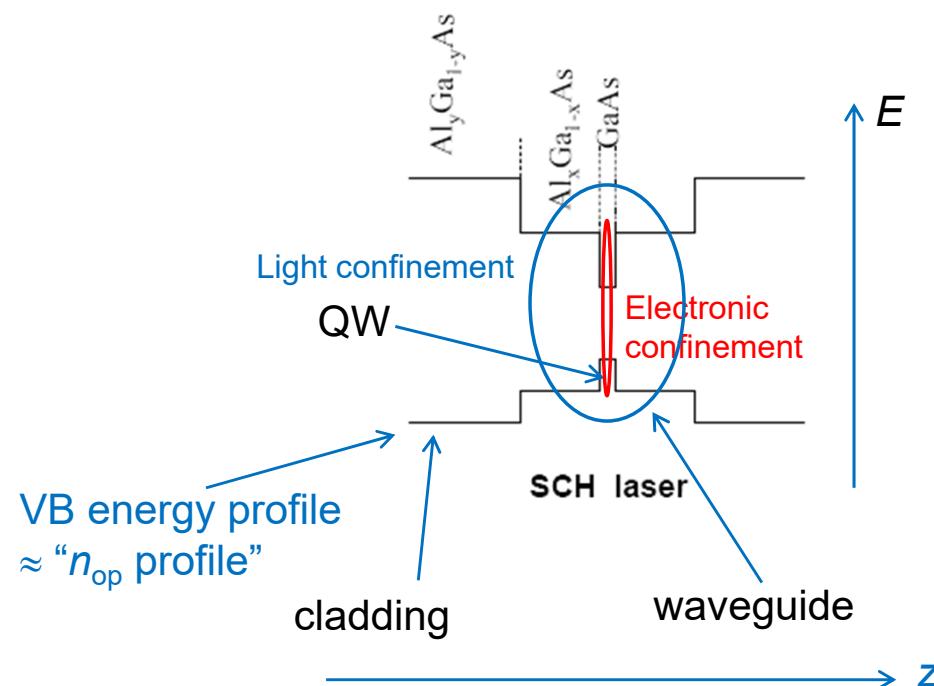


0.2-1  $\mu\text{m}$  x 2-5  $\mu\text{m}$  x 200-1000  $\mu\text{m}$



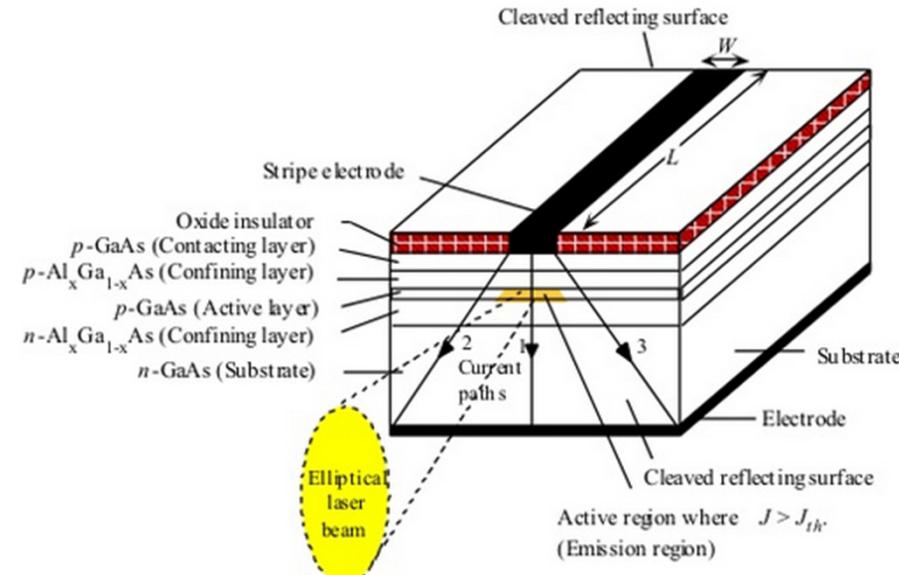
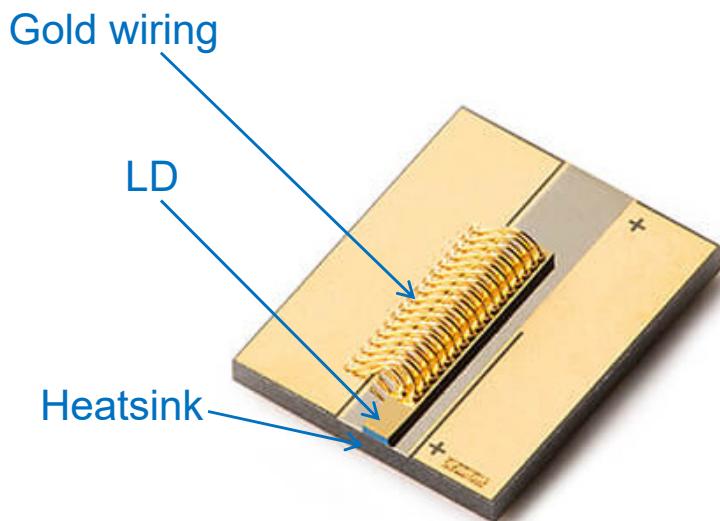
Index-guided LD structures (600 x 2  $\mu\text{m}^2$ )

“LED” + cavity (mirrors)



SCH: separate confinement heterostructure

# Edge-emitting laser diode



II-VI Inc. high output power (12 W, cw) near-infrared single mode edge emitting laser diode (single QW)

# Edge-emitting laser diode

## Internal efficiency

The output power is given by:

$$P_s = \eta(h\nu/q)(I - I_{\text{thr}}) \quad \text{with } \eta = \eta_i \alpha_m / (\alpha_m + \alpha_p) = \eta_i \ln(1/R_m) / [\alpha_p L + \ln(1/R_m)]$$

with  $R_m$  the mirror reflectivity (taken identical for both sides)

## External differential quantum efficiency:

$$\eta_d = \left( \frac{dP_s}{dI} \right) \left( \frac{q}{h\nu} \right) \quad (I > I_{\text{thr}})$$

$$\text{Thus } \eta_d = \frac{\eta_i}{\left[ 1 + \alpha_p L / \ln\left(\frac{1}{R_m}\right) \right]}$$

Internal quantum efficiency

